U.S. **UTILITY** Patent Application

	O.I.P.E.		PATENT DATE
SCANNED	Q.A.		

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/749171		438	4	1765	

APPLICANTS

Cleopatra Cabuz
Jeffrey Ridley

TITLE

Thin silicon micromachined structures

PTO-2040
12/99

ISSUING CLASSIFICATION

ORIGINAL		CROSS REFERENCE(S)							
CLASS	SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)						
438	52	437	53	456					

INTERNATIONAL CLASSIFICATION							
H01L	21/00						
H01L	21/30, 21/46						

☐ Continued on Issue Slip Inside File Jacket

☐ **TERMINAL DISCLAIMER**

☐ The term of this p
subsequent to
has been disclaimed.

☐ The term of this p
not extend beyond the
of U.S Patent No.

☐ The terminal
this patent have been

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DRAWINGS			CLAIMS ALLOWED	
Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
(Assistant Examiner)		(Date)	**NOTICE OF ALLOWANCE MAILED**	
			ISSUE FEE	
			Amount Due	Date Paid
(Primary Examiner)		(Date)		
			ISSUE BATCH NUMBER	
(Legal Instruments Examiner)		(Date)		

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